

MAIL STOP: RCE  
PATENT  
3511-1033

IN THE U. S. PATENT AND TRADEMARK OFFICE

In re application of

Liro HIETANEN et al. Conf. 6321

Application No. 10/533,645 Group 2877

Filed: January 13, 2006 Examiner Rebecca Slomski

Title: SYNCHRONOUS OPTICAL MEASUREMENT  
AND INSPECTION METHOD AND MEANS

AMENDMENT

MAIL STATION: RCE October 22, 2008  
Assistant Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the final Office Action mailed July 22, 2008, Request for Continued Examination being concurrently filed, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins 2 of this paper.

Remarks begin 12 of this paper.